



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

) Group Art Unit: 2818

Toru TAKAYAMA et al.

) Examiner: T. Le

Serial No. 10/664,866

) CERTIFICATE OF MAILING

Filed: September 22, 2003

) I hereby certify that this correspondence is
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For: METHOD FOR MANUFACTURING

)

SEMICONDUCTOR DEVICE AND

)

HEAT TREATMENT METHOD

) Adrian M. Stamps

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents

P.O. Box 1450

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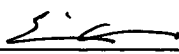
Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

Respectfully submitted,


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